



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 12, 2026

IGI Report Number

LG800607772

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

6.44 - 6.47 X 3.93 MM

GRADING RESULTS

Carat Weight

1.01 CARAT

Color Grade

D

Clarity Grade

VS 1

Cut Grade

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

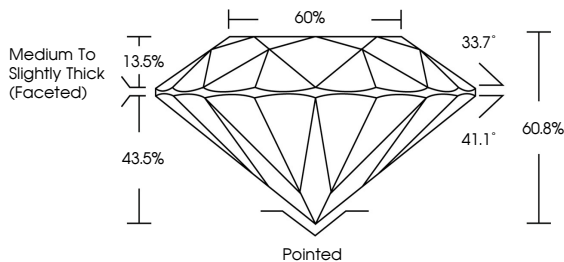
NONE

Inscription(s)

 LG800607772

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

60%

33.7°

41.1°

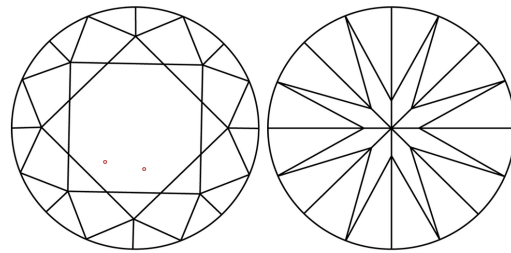
60.8%

43.5%

13.5%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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Carat Weight

1.01 CARAT

Color Grade

D

Clarity Grade

VS 1

Cut Grade

IDEAL

Depth

60.8%

Table

66%

Girdle

Medium To Slightly Thick (Faceted)

Culet

Pointed

Polish

EXCELLENT

Symmetry

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Fluorescence

NONE

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